

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

IN RE APPLICATION OF: Cheng Guo et al.

§ GROUP ART UNIT: 1756

§ (Parent Application)

SERIAL NO.: Not yet assigned

§ EXAMINER: S. R. Mohamedulla

FILED: March 5, 2004

§ (Parent Application)

FOR: STRUCTURES USEFUL IN ELECTRON  
BEAM LITHOGRAPHY

§ Attorney Docket No.:

§ AM-5264.D1

Date: March 3, 2004

**PRELIMINARY AMENDMENT "A"**

**Hon. Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450**

Sir:

This Preliminary Amendment "A" accompanies a divisional application of U.S. Application Serial No. 09/698,706, filed October 27, 2000.

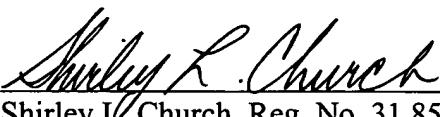
Please amend the application as follows:

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**CERTIFICATE OF MAILING UNDER 37 CFR § 1.10**

I hereby certify that this paper is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as U.S. EXPRESS MAIL NO. ER534274308US in an envelope addressed to: Mail Stop Patent Application, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Date: March 3, 2004

  
\_\_\_\_\_  
Shirley L. Church, Reg. No. 31,858

IN THE TITLE:

At page 1, line 1, please delete the Title in its entirety, and replace with the following Title:

-- STRUCTURES USEFUL IN ELECTRON BEAM LITHOGRAPHY --